

## 7<sup>th</sup> IEEE Electron Devices Technology and Manufacturing (EDTM) Conference 2023

March 7 – 10, 2023 / COEX Seoul, Korea

8A. Advanced Interposer RDL Technology	
Session Date:	March 8(Wed.), 2023
Session Time:	13:30-14:55
Session Room:	Room A (#301)
Session Chair:	Prof. Bong-Young Yoo (Hanyang University)
	Dr. Akihiro Horibe (IBM Research Tokyo)
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[8A-1] [Invited]	13:30-13:55
Interposer Trends and Technologies of Heterogeneous Integration	
Gu-Sung Kim	
Kangnam University	
[8A-2]	13:55-14:10
On-Chip Canary Circuit Design for Electronic Interconnects by Utilizing RF Resonance Peak	
Movement as a Prognostic Factor	
Tae Yeob Kang <sup>1</sup> , Donghwan Seo <sup>1</sup> and Taek-Soo Kim <sup>2</sup>	
<sup>1</sup> Agency for Defense Development, <sup>2</sup> Korea Advanced Institute of Science and Technology	
[8A-3] 14:10-14:25	
Mathematical Optimization Models for Auto Interposer Routing Problem for Improving	
Signal Integrity	
Taewook Kang, Youjung Lee, Joonrak Kim, Joohwan Cho, Sangho Lee, Bumsu Kim, Wontae Kim	
and Sijeo Park	
SK hynix	
[8A-4]	14:25-14:40
Selective Cu Electrodeposition for Through Glass Via (TGV)	
Fan Yang, Qing Wang, Jinhyun Lee, Sanghwa Yoon and Bongyoung Yoo	
Hanyang University	
[8A-5] 14:40-14:55	
Effect of Photo-Definable Dielectric Process Conditions on the Interfacial Reliabilities of	
Polyimide Capping Layer/ Cu RDL for Fan-Out	
Gahui Kim, Doheon Kim and Young-Bae Park	
Andong National University	